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18 May 2004  
Date of Deposit

Paul E. Rauch, Ph.D.  
Name of Applicant, Assignee or  
Registered Representative

  
Signature

Our File No.: CYP01-002-US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: H. Bamnolker et al. )

Serial No.: 09/927,863 )

Filing Date: August 10, 2001 )

For: METHODS OF FORMING )  
SEMICONDUCTOR )  
STRUCTURES HAVING )  
REDUCED DEFECTS, AND )  
ARTICLES AND DEVICES )  
FORMED THEREBY )

Examiner: Lynette T. Umez-Eronini

Group Art Unit No.: 1765

Enter Amendment  
L.T.U.E.

**REQUEST FOR RECONSIDERATION**

5/31/2004

M.S. - AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Responsive to the Office Action of December 18, 2003, Applicants respectfully request reconsideration in light of the following remarks.